

<b>Notice of References Cited</b>	Application/Control No. 10/594,283		Applicant(s)/Patent Under Reexamination PENALVA, JOAQUIN ESPUELA	
	Examiner PETER Y. CHOI		Art Unit 1794	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,514,306	02-2003	Rohrbach et al.	55/524
*	B	US-6,319,356	11-2001	Durkes et al.	162/5
*	C	US-2003/0205137	11-2003	Bolduc, Normand	95/285
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U				
	V				
	W				
	X				

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.